



PATENT
8017-1094

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Toshiji TAIJI et al.

Conf. 2404

Application No. 10/616,914

Group 1765

Filed July 11, 2003

Examiner L. Umez Eronini

SLURRY FOR CHEMICAL MECHANICAL POLISHING

RESPONSE

Assistant Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

November 15, 2006

Sir:

This responds to the Official Action of July 24, 2006.

Remarks begin on page 2 of this paper.